

09/590,621

L Number	Hits	Search Text	DB	Time stamp
1	51	("3843427") or ("3953756") or ("4091305") or ("4183125") or ("4292092") or ("4422731") or ("4451759") or ("4749840") or ("4874461") or ("4892592") or ("4923421") or ("4973378") or ("5011391") or ("5083958") or ("5129850") or ("5205770") or ("5232549").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/27 13:34
2	0	((("3843427") or ("3953756") or ("4091305") or ("4183125") or ("4292092") or ("4422731") or ("4451759") or ("4749840") or ("4874461") or ("4892592") or ("4923421") or ("4973378") or ("5011391") or ("5083958") or ("5129850") or ("5205770") or ("5232549").PN.) and stereolithographs	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/27 13:35
3	4	(machine near6 vision) and stereolithographs	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/27 13:36
-	2	("6000000").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:43
-	10568	"flip chip"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:44
-	10040	"flip chip" and @ad<20000608	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:44
-	2218	"flip chip" and @ad<20000608) and support	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:45
-	433	((("flip chip" and @ad<20000608) and support) and photoresist	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:45
-	253	((("flip chip" and @ad<20000608) and support) and photoresist) and wafer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:46
-	67	((("flip chip" and @ad<20000608) and support) and photoresist) and wafer) and column	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 17:46

09/590,621

-	25	((("flip chip" and @ad<20000608) and support) and photoresist) and wafer) and column) and laminates\$	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 18:19
-	1143	stereolithograph\$	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 18:21
-	51	stereolithograph\$ and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 18:24
-	40	(stereolithograph\$ and semiconductor) and locat\$	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 18:25
-	29	((stereolithograph\$ and semiconductor) and locat\$) and substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/09/26 18:26